

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Mazumder et al.

Serial No.: 09/916,566

Group No.: 2123

Filed: July 27, 2001

Examiner: Z. Cabrera

For: DIRECT METAL DEPOSITION APPARATUS UTILIZING RAPID-RESPONSE DIODE
LASER SOURCE

AMENDMENT UNDER 37 CFR §1.312

Mail Stop ISSUE FEE
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Prior to issuance, please amend the above-referenced application as follows: